

Workshop on sapphire detector construction

Thursday, 11 January 2024

Measuring CCE and mu-tau for sapphire sensors: Measuring CCE and mu-tau for sapphire sensors (12:05 - 13:05)

time	[id] title	presenter
12:05	[12] Measurements of CCE with pad sensors and an alpha source, plasma effects	MORANDIN, Mauro
12:15	[13] Measurements of CCE with pad sensors with a low intensity electron beam	GRUTTA, Pietro
12:25	[15] Discussions: how to improve the current evaluations of CCE and mu-tau	ALL